

<b>Notice of References Cited</b>	Application/Control No. 10/572,689	Applicant(s)/Patent Under Reexamination TATENO, KOUICHI	
	Examiner Michael C. Wimer	Art Unit 2821	Page 1 of 1

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-5,757,327	05-1998	Yajima et al.	343/713
	B	US-			
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	D	US-			
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**FOREIGN PATENT DOCUMENTS**

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**NON-PATENT DOCUMENTS**

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